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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

**Group Art Unit: 2812  
Examiner: Stanetta D. Isaac**

**In Re PATENT APPLICATION of:**

Applicant(s): Jun KANAMORI

Serial No.: 10/634.851

Filing Date: August 6, 2003

**For:** SEMICONDUCTOR DEVICE  
FABRICATION METHOD USING  
OXYGEN ION IMPLANTATION

Atty. Dkt.: MAE 292

## **AMENDMENT**

February 24, 2005

**Mail Stop Amendment**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Examiner's Action mailed on August 25, 2004, the period for response to which is extended by a Petition for a Three-month Extension of Time filed herewith, please amend the above-identified application as follows:

**FEE ENCLOSED:\$1020.00**  
Please charge any further  
fee to our Deposit Account  
No. 18-0002